

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Joseph M. Amato

Group Art Unit: 2823

Serial No.: 10/567,173

Examiner: Lee, Hsien Ming

Filed: February 3, 2006

Confirmation No.: 9635

For: OFFSET DEPENDENT RESISTOR FOR MEASURING MISALIGNMENT OF
STITCHED MASKS

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE TO OFFICE ACTION

Sir:

In response to the Office Action mailed October 28, 2008, please find the
following:

Amendments to the Claims are reflected in the listing of claims which begins on page 2
of this paper.

Remarks/Arguments begin on page 10 of this paper.

CERTIFICATE OF MAILING UNDER 37 C.F.R. 1.8

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being
facsimile transmitted to the Patent and Trademark Office on the date shown below.

Date: _____

Signed: _____

Typed Name: Mark A. Wilson